Construction of a Semiconductor–Biological Interface for Solar Energy Conversion: p-Doped Silicon/Photosystem I/Zinc Oxide

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ABSTRACT: The interface between photoactive biological materials with two distinct semiconducting electrodes is challenging both to develop and analyze. Building off of our previous work using films of photosystem I (PSI) on p-doped silicon, we have deposited a crystalline zinc oxide (ZnO) anode using confined-plume chemical deposition (CPCD). We demonstrate the ability of CPCD to deposit crystalline ZnO without damage to the PSI biomaterial. Using electrochemical techniques, we were able to probe this complex semiconductor–biological interface. Finally, as a proof of concept, a solid-state photovoltaic device consisting of p-doped silicon, PSI, ZnO, and ITO was constructed and evaluated.

INTRODUCTION

Over the course of billions of years of evolution, nature has developed a remarkable set of nanomaterials capable of photochemical conversion with efficiencies not currently possible using man-made materials. Of particular interest for solar energy conversion is a membrane protein found in the thylakoids of higher-order plants known as photosystem I (PSI). PSI is capable of photoexciting electrons with an internal quantum efficiency near unity.¹ This efficiency, coupled with its natural abundance and ease of extraction, has led researchers across the globe to integrate this biomaterial into photovoltaic and photoelectrochemical devices.²–⁴ The efficiency of PSI stems from its ability to quickly transport the photoexcited electron from the P700 reaction center (located on the luminal side of the membrane) to the F₈ site (located on the stromal side of the membrane) through an internal electron transfer chain. This separates the photoinduced electron–hole pair both spatially and energetically. In nature the photoexcited electron is collected by the water-soluble redox protein ferredoxin, while the water-soluble redox protein plastocyanin delivers another electron to the oxidized P700 reaction center.⁵ In artificial biohybrid devices, these redox proteins are replaced with electrodes and electrochemical mediators.²

While metal electrodes have traditionally been used in artificial PSI devices, semiconducting electrodes have been shown to provide significant improvements in photocurrent and photovoltage production.⁶–¹³ p-doped silicon was found to be an excellent platform for electron donation to the P700 reaction center.¹² Additionally, Mershin and co-workers found that ZnO was able to accept the electrons from the F₈ site of PSI.¹² Furthermore, because of the large band gap in ZnO, this semiconductor is transparent to visible light and can therefore serve as the transparent electrode, allowing light to reach the photoactive layer. We now report the fabrication of an electrochemically active p-doped silicon/PSI/ZnO multilayer electrode and the incorporation of this electrode into a functional p-doped silicon/PSI/ZnO/ITO solid-state photovoltaic device (Figure 1).

Simultaneously interfacing a PSI film with p-doped silicon and n-type ZnO presents several challenges. Due to the organic nature of PSI, any high-temperature processing and harsh

Figure 1. Illustration of the various components in the reported solid-state device along with their band energies.

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chemical treatments must be performed prior to PSI film deposition. In other words, one of the semiconductors will need to be deposited under mild conditions. We address this issue by employing a relatively new deposition technique known as confined-plume chemical deposition (CPCD) to fabricate PSI/ZnO bilayers which exhibit good electrical contact.14 These bilayers were then incorporated into a functional p-doped silicon/PSI/ZnO/ITO solid-state photovoltaic device.

To our knowledge, this is the first demonstration of depositing a crystalline ZnO film directly onto a biological material without the use of seeding crystals. Additionally, it represents one of only a few reported methods for incorporating PSI reaction centers into a solid-state device and the only one using two semiconductor electrodes to maximize the unidirectional current flow through the PSI layer.15,16

### EXPERIMENTAL SECTION

#### Preparation of Substrates.
Lightly p-doped (boron dopant density = 10^16 cm^-3) silicon substrates were purchased from University Wafer (Boston, MA). In most experiments, the silicon substrate was used as received. For specific experiments (as described in the text) the native oxide layer on the silicon substrate was etched with a 2% hydrogen fluoride solution. (Caution! Hydrogen fluoride is extremely corrosive and dangerous.) Proper protective equipment and procedures should always be used. Immediately following etching, the silicon substrates were rinsed with copious amounts of deionized water.

#### Extraction of Photosystem I.
Photosystem I complexes from commercially available baby spinach were isolated using previously described methods. Briefly, thylakoid membranes were isolated from spinach leaves via maceration and subsequent centrifugation at 4000g.17 The PSI complex was then removed from the thylakoid membrane by adding a high concentration of surfactant, followed by further centrifugation.18 The protein was then purified using a chilled hydroxyapatite column. Following elution, excess surfactant and salt were removed via dialysis.19 The concentration of the resulting PSI solution consisted of 1.7 × 10^{-4} M active P700 reaction centers with a chlorophyll a/b ratio of 3.5 as characterized by the methods of Porra and Baba et al., respectively.20,21

#### Modification of Substrates with Photosystems I.
Films of PSI were deposited onto the silicon substrates following the procedure previously developed by Ciesielski and co-workers.22 Briefly, 60 or 160 μL of PSI extract solution was pipetted onto the silicon substrate (exposed area of 0.385 or 1.000 cm²), and a vacuum was applied to remove any solvent. Due to the low surfactant concentration in the protein suspension, the resulting protein film was no longer water soluble and could withstand electrochemical experiments using aqueous mediators. The thickness of the protein film can be easily increased by adding additional deposition steps or decreased by diluting the concentration of the initial solution. Film thicknesses were determined using a Vecco Dektak 150 stylus profilometer. For these measurements the protein film was scratched to the underlying silicon substrate, and the profilometer step height from the top of the film to the underlying substrate was used to determine the average thickness of the films (~0.5 μm).

#### CPCD of ZnO.
CPCD was performed following the same concept described by Ivanov and co-workers.23 Here, the ZnO precursor, Zn(CO)₂(OH)₂ (hydroxozincate), was synthesized by a method similar to that of Wahab and co-workers.24 Hydroxozincate was suspended in benzene (10 mM) and drop cast onto the PSI-modified silicon electrode (10 μL). After drying in air, the sample was confined using a glass slide and a custom-made aluminum frame. The sample was then irradiated using a tabletop 2.94 μm Er:YAG (yttrium aluminum garnet) laser with a pulse duration of 150 μs. The laser was focused using a cylindrical ZnSe lens resulting in a beam area roughly 500 μm × 12.5 mm. The laser, with an energy output of 100 mJ, was pulsed at 20 Hz and was scanned twice over the surface of the sample at a rate of 317 μm s⁻¹. The sample was then removed from confinement, and compressed air was used to remove excess ZnO and carbon material.

#### ZnO Characterization.
After modification with ZnO, the samples were characterized using a number of analytical techniques. SEM was performed using a Hitachi S4200 at an accelerating voltage of 10 kV. Energy-dispersive X-ray analysis was performed using a Zeiss Merlin at an accelerating voltage of 10 kV. Powder X-ray diffraction scans were obtained on a Scintag X1 θ/θ automated powder X-ray diffractometer with a Cu target (1.5418 Å), a Peltier-cooled solid-state detector, and a zero-background Si(510) sample support.

#### Electrochemical Measurements.
Electrochemical measurements were performed using a CH Instruments (Austin, TX) CHI 660a electrochemical workstation. The silicon substrate was set as the working electrode, Ag/AgCl (3 M KCl) was used as the reference electrode, and platinum mesh was used as a counter electrode. Electrochemical mediator solutions consisted of 100 mM potassium chloride (Sigma-Aldrich) and 2 mM hexaammineruthenium(III) chloride (RuHex) (Sigma-Aldrich) or 2 mM methyl viologen dichloride hydrate (MV) (Sigma-Aldrich).

#### Solid-State Device Fabrication.
Solid-state devices were fabricated using ITO-coated PET (60 Ω square⁻¹, Sigma-Aldrich) to make electrical contact with the ZnO layer. In order to generate as much contact as possible with the rough ZnO layer, a small piece of transparent PET was pressed onto the ITO electrode. (Caution! Hydrogen fluoride is extremely corrosive and dangerous.) Proper protective equipment and procedures should always be used. Immediately following etching, the silicon substrates were rinsed with copious amounts of deionized water.

#### RESULTS AND DISCUSSION

Previous work has demonstrated that depositing PSI films onto p-doped silicon resulted in significant photocurrent enhancement when compared to more traditional metal electrodes (i.e., gold).11 Unfortunately, this system required the electrochemical mediator methyl viologen (MV). In addition to the toxic nature of MV, the use of an electrochemical mediator produces a number of problems such as the corrosion of metal electrodes, limitations in the mass transfer of soluble mediators, and device failure caused by leaks. Therefore, the development of a solid-state device is much more appealing for practical applications.

To develop a solid-state system, a material with the proper energy alignment with the FB site of PSI is critical to facilitating electron transfer. As seen in Figure 1, the conduction band of ZnO lies below the formal potential of PSI’s FB site. Unfortunately there are few, if any, reported methods for depositing a layer of ZnO that would be in sufficient contact with the rough film of PSI for efficient interfacial electron
transport. While there are several methods for chemically depositing zinc oxide, all require temperatures greater than 70 °C. Since the deposition of ZnO at these temperatures could denature the protein complex, an alternative deposition method must be investigated. Therefore, we employed a relatively new technique, CPCD, that has been used previously to rapidly deposit crystalline ReB2, RuB2, WB4, and B4Co n various substrates without collateral thermal damage.14

In CPCD (Figure 2), the irradiation of appropriate molecular precursors spatially confined between two support plates by a beam of pulsed infrared (IR) laser light leads to rapid precursor decomposition, the formation of a visible reaction plume under spatial and temporal confinement, and the deposition of crystalline ceramic material of high purity as the laser beam is rastered across the specimen. Pulse energy analysis reveals that 75–95% of the IR light energy is absorbed during precursor decomposition, thus permitting the use of either hard or soft support materials. Rapid cooling of reaction plume species leads to the surface-nucleated growth of crystalline, ceramic micro-crystals, without the need for subsequent thermal annealing.

CPCD of a hydrozincite [Zn5(CO3)2(OH)6] solution drop cast onto a thin film of PSI on p-doped silicon forms a dull translucent film on the surface of the PSI layer. XRD analysis of this film reveals crystalline, wurtzite ZnO as the primary product (Figure 3). SEM images indicated that the ZnO forms a continuous particulate layer directly on the protein, as confirmed by energy-dispersive X-ray (EDS) analysis (Figure 4, Figure S2).

To confirm that CPCD processing leaves the underlying PSI film undamaged, photochronoamperometry was performed using an actinic light source. As seen in Figure 5, the deposition of a ZnO layer not only allows the PSI to remain photoactive but also significantly enhances the photocurrent density of the system when a hexaaammineruthenium(iii) chloride (RuHex) solution...
mediator is employed. ZnO facilitates electron transfer from the $F_0$ site of PSI to the RuHex mediator because the conduction band of ZnO ($-4.25$ eV) lies between the formal potentials of $F_0$ and RuHex ($-4.10$ and $-4.60$ eV, respectively). When MV is used as a mediator, no enhancement is observed because the formal potential of MV ($-4.05$ eV) is higher than the conduction band of the ZnO. It is worth noting, however, that the photocurrent difference was insignificant between the samples with and without ZnO when MV was used, providing further evidence that CPCD deposition does not damage the PSI film. Higher photocurrents with a zinc oxide layer using methyl viologen as a mediator can be achieved by etching the silicon prior to the photocronoamperometry experiments.\(^{11}\)

After observing this enhancement in photocurrent from the additon of a ZnO layer, the p-doped silicon/PSI/ZnO trilayer biohybrid electrode can be transformed into a solid-state photovoltaic device by placing ITO-coated PET in contact with the ZnO layer as an anodic electrode (Figure S1). Photocronoamperometric analysis (Figure 6) reveals that this device not only improves upon the photocurrent density but also changes the shape of the curve when compared to an electrochemical cell. The use of an electrochemical mediator introduces diffusion mass-transfer limitations in the cell as indicated by the time decay in the photocurrent, which follows Cottrell behavior for diffusion-controlled current, while the solid-state device does not have this decay in current.

With a solid-state device in hand, current–voltage ($I$–$V$) analysis revealed the efficiency and other performance metrics of this device under calibrated solar illumination (Figure 7). The unetched Si device had a photocurrent density of 21 $\mu$A cm\(^{-2}\) and an external efficiency of 0.0015%. When the p-doped silicon substrate was etched with hydrofluoric acid before the deposition of the PSI layer, a 6-fold improvement in the photocurrent density (127 $\mu$A cm\(^{-2}\)) and a 5-fold increase in the efficiency (0.0077%) of the final device were observed. Although the photocurrent density increased with the removal of the insulating SiO\(_2\) layer, by lowering the internal resistance of the device, a drop in the open circuit voltage was also observed. This might be attributed to the loss of the Shottky barrier in the device. IPCE spectra were taken of devices with and without the presence of photosystem I, indicating that photosystem I is indeed the light-active portion of the device (Figure S4). Although the efficiencies for the above cells are low, this fabrication technique has an overall low cost and allows for the rapid preparation of devices. Further optimization of device architecture will likely provide further improvements in both efficiency and photocurrent density.

Of great concern when using a biological material in solar energy technology is device longevity. Previous photoelectrochemical devices employing PSI have shown consistent photocurrent values for over 280 days.\(^{22}\) To address long-term performance, five solid-state devices were tested, after 10 s of illumination, over a period of 2 weeks (Table 1). Two of the devices (B and E) showed very good stability over the course of 2 weeks, with a reduction in less than 10% of the initial photocurrent. The other three (A, C, and D) showed less than a 30% reduction in initial photocurrent over a period of 2 weeks. Device exposure to long, intense light for over 67 h also resulted in no significant photocurrent degradation (Figure S5).

### Table 1. Photocurrent Output ($\mu$A cm\(^{-2}\)) of Five Unetched Solid-State Devices over a Period of 2 Weeks

<table>
<thead>
<tr>
<th>Device</th>
<th>1</th>
<th>2</th>
<th>3</th>
<th>4</th>
<th>5</th>
<th>6</th>
<th>7</th>
<th>8</th>
<th>13</th>
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<th>RSD %</th>
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<tr>
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<td>3.97</td>
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<td>2.67</td>
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<tr>
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<td>4.8</td>
<td>4.6</td>
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<td>10</td>
</tr>
<tr>
<td>C</td>
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<td>11.8</td>
<td>7.32</td>
<td>11.3</td>
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<td>6.61</td>
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<td>7.7</td>
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</tr>
<tr>
<td>D</td>
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<td>17.3</td>
<td>16.4</td>
<td>14.2</td>
<td>14.4</td>
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Figure 7. $I$–$V$ analysis of a solid-state device composed of etched (left) and unetched (right) p-doped silicon, a film of PSI, CPCD ZnO, and an ITO contact and control samples composed of p-doped silicon, CPCD ZnO, and an ITO contact. Samples were tested under 1 sun illumination (red) and in the dark (black).
While the overall efficiency of the devices tested is relatively low, this study demonstrates an important proof of concept that will inevitably provide a pathway to more efficient devices based on the trajectory of other biohybrid electrodes.

More broadly, using CPCD to deposit crystalline materials on biological and other temperature-sensitive substrates without the need for seeding is beneficial for a variety of applications. Additionally, the use of electrochemical mediators to probe electronic interactions between semiconductor–biological interfaces has applications in several different fields, specifically biosensors and bioelectronics.

## ASSOCIATED CONTENT

### Supporting Information

The Supporting Information is available free of charge on the ACS Publications website at DOI: 10.1021/acs.langmuir.5b02334.

Additional data describing the fabrication and electrochemical characterization of solid-state devices and SEM images of the ZnO layer (PDF)

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Authors J.C.B. and G.L. contributed equally to this work. The manuscript was written through the contributions of all authors. All authors have given approval to the final version of the manuscript.

### Notes

The authors declare no competing financial interest.

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## ABBREVIATIONS

PSI, photosystem I; ITO, indium tin oxide; CPCD, confined-plume chemical deposition; MV, methyl viologen dichloride hydrate; RuHex, hexaammineruthenium (iii) trichloride; Er:YAG, erbium-doped yttrium aluminum garnet; CV, cyclic voltammetry

## REFERENCES


